

JUL 14-05 13:22

FROM-BEUSSE BROWNLEE ET AL

4079267720

T-284 P.01/05 F-633

BEUSSE BROWNLEE WOLTER  
MORA & MAIRE, P.A.

RECEIVED  
CENTRAL FAX CENTER  
JUL 14 2005

—————  
FACSIMILE TRANSMITTAL SHEET  
—————

TO: \_\_\_\_\_ FROM: \_\_\_\_\_

James H. Beusse

Maria F. Guerrero  
Art Unit: 2822

COMPANY:	DATE:
U.S. Patent Office	July 14, 2005
FAX NUMBER:	TOTAL NO. OF PAGES INCLUDING COVER:
703-872-9306 – Central Fax No.	5
PHONE NUMBER:	SENDER'S REFERENCE NUMBER:
1-866-217-9197	075903-284
RE:	YOUR REFERENCE NUMBER:
09/699,975	

URGENT  FOR REVIEW  PLEASE COMMENT  PLEASE REPLY  PLEASE RECYCLE

NOTES/COMMENTS

RESPONSE TO OFFICE ACTION OF APRIL 15,  
2005.

Please confirm receipt.

THANKS.

—————  
990 NORTH ORANGE AVENUE, SUITE 2500, ORLANDO, FLORIDA 32801  
TELEPHONE: (407) 926-7700 FAX: 407-926-7720

Jessen 7-1-4

RECEIVED  
CENTRAL FAX CENTER

JUL 14 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Applicant: Isaiah O. Oladeji et al.

Examiner: Maria F. Guerrero

Serial No.: 10/699,975

Art Unit: 2822

Filed: 11/03/2003

Conf. No.: 5032

For: Mask Layer And Interconnect  
Structure For Dual Damascene  
Semiconductor ManufacturingMail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

This paper is in response to the Office Action, dated as mailed April 15, 2005 and having a response due date of July 15, 2005.

Please proceed to the following page.